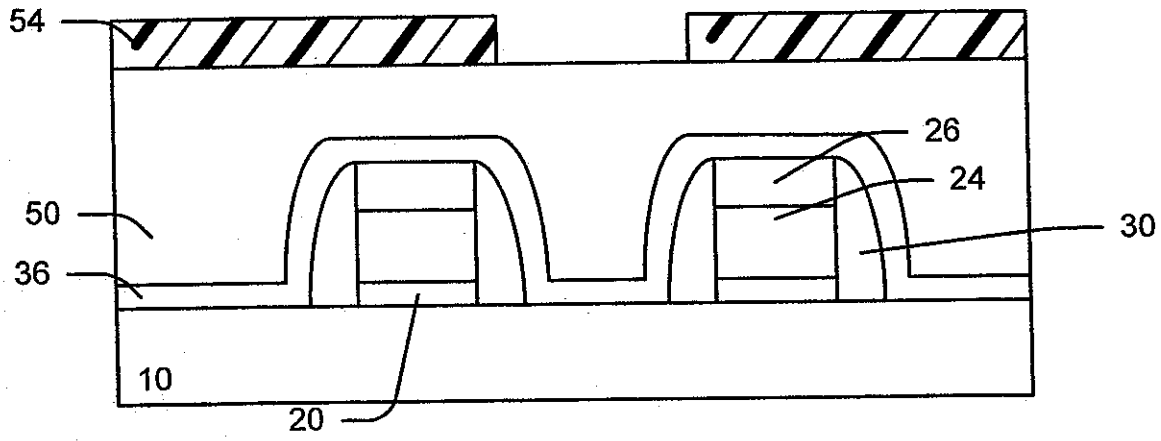


FIGURE 1

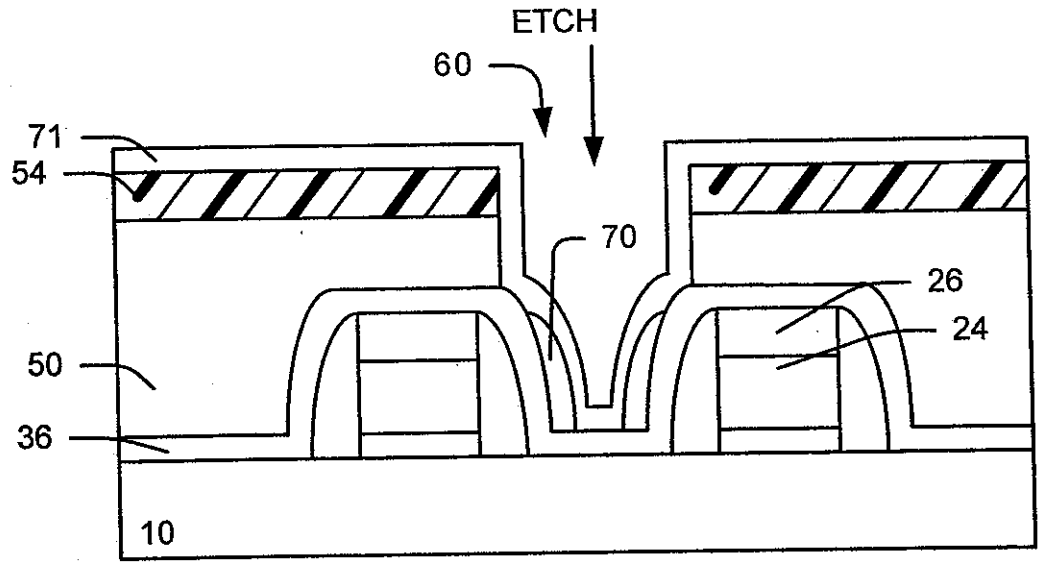


FIGURE 2

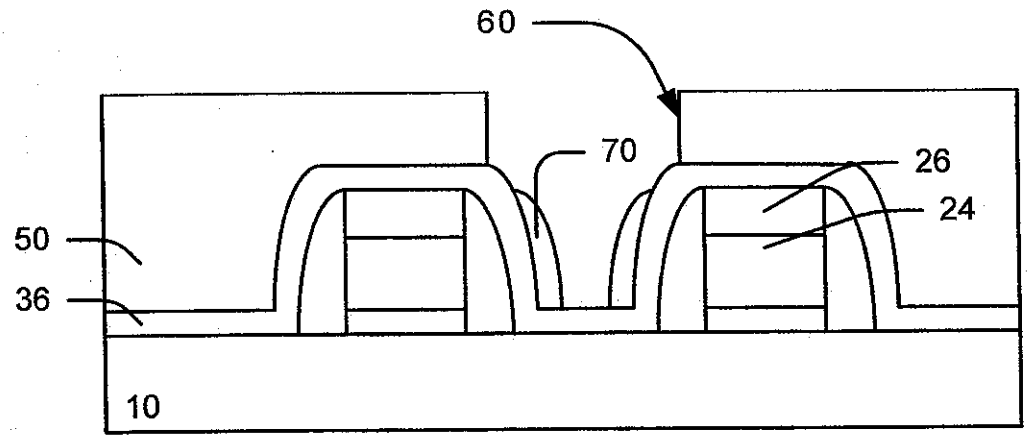


FIGURE 3

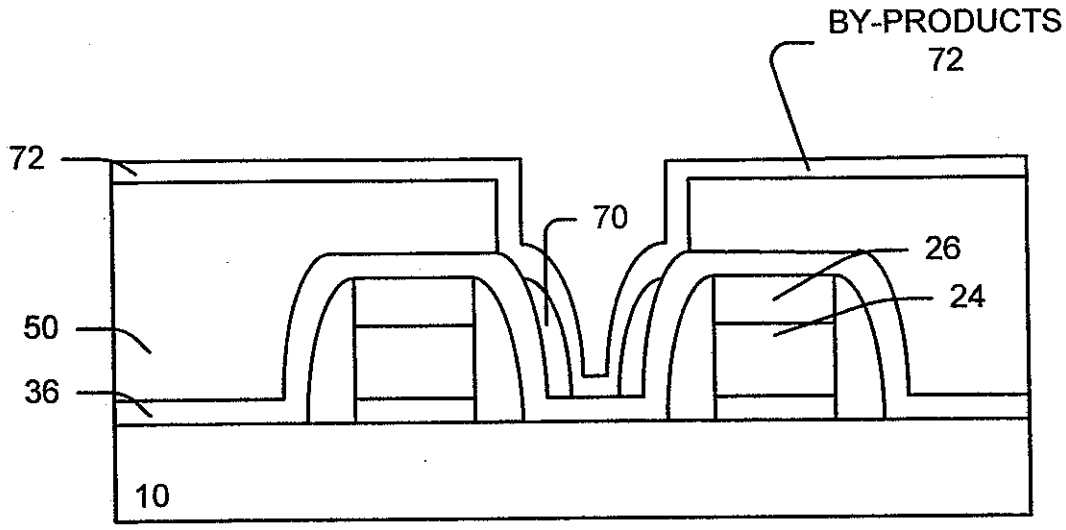


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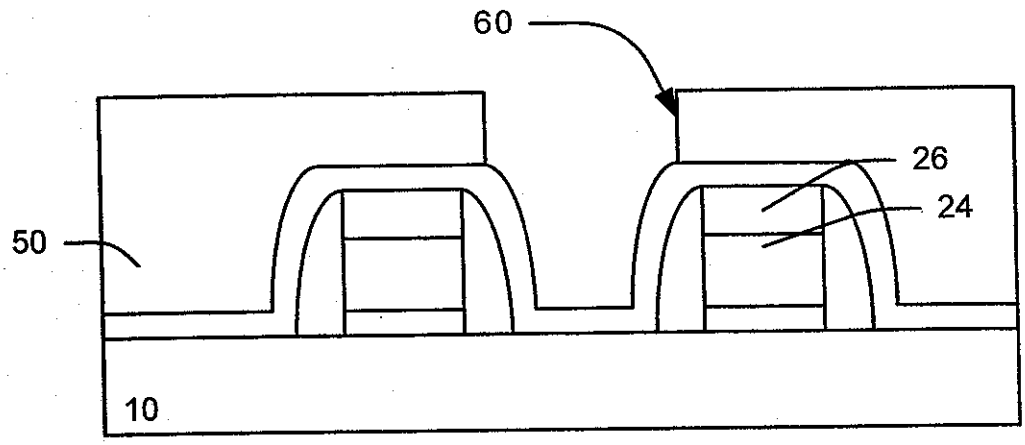


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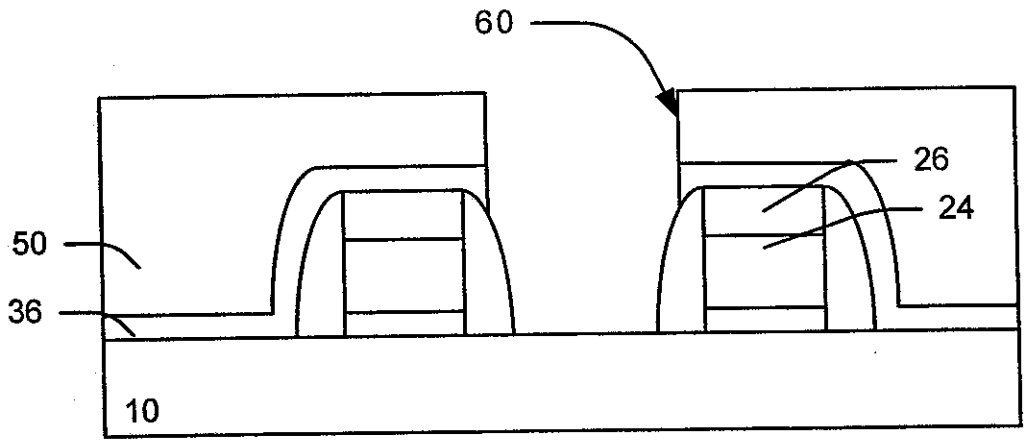


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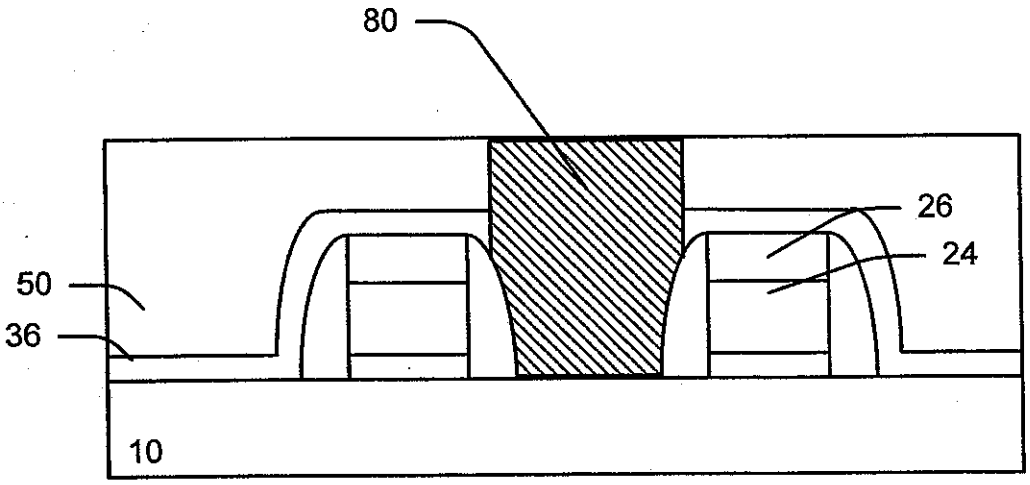


FIGURE 7

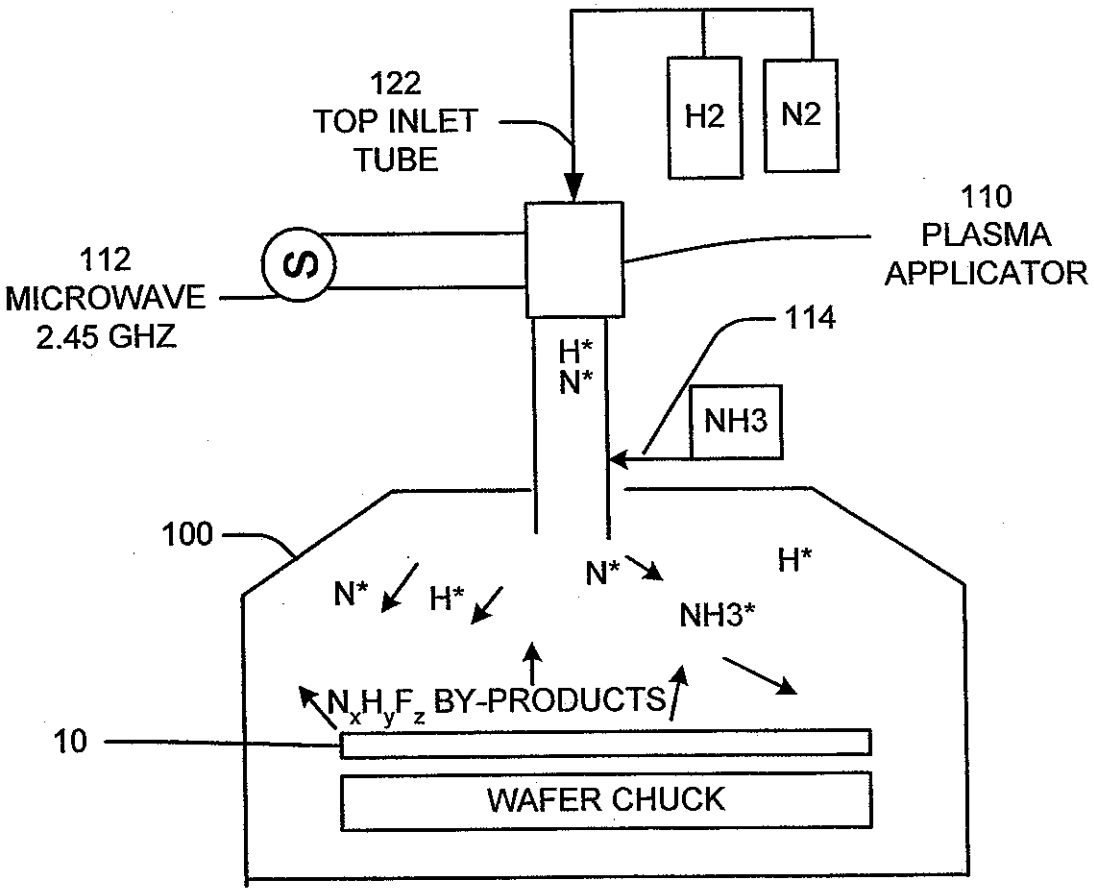


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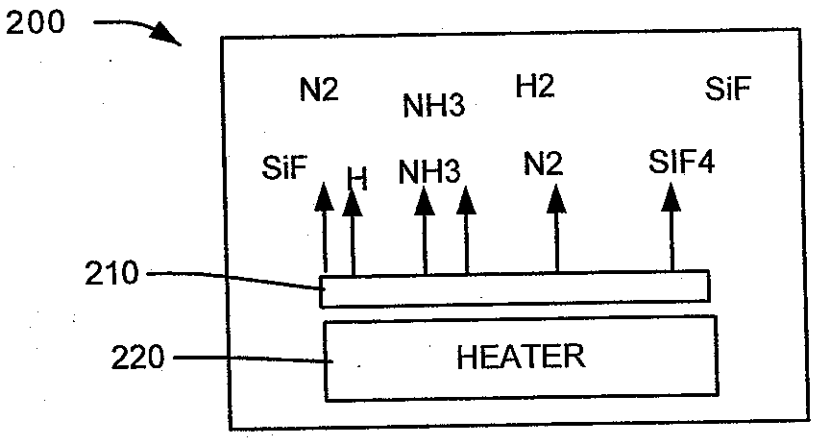


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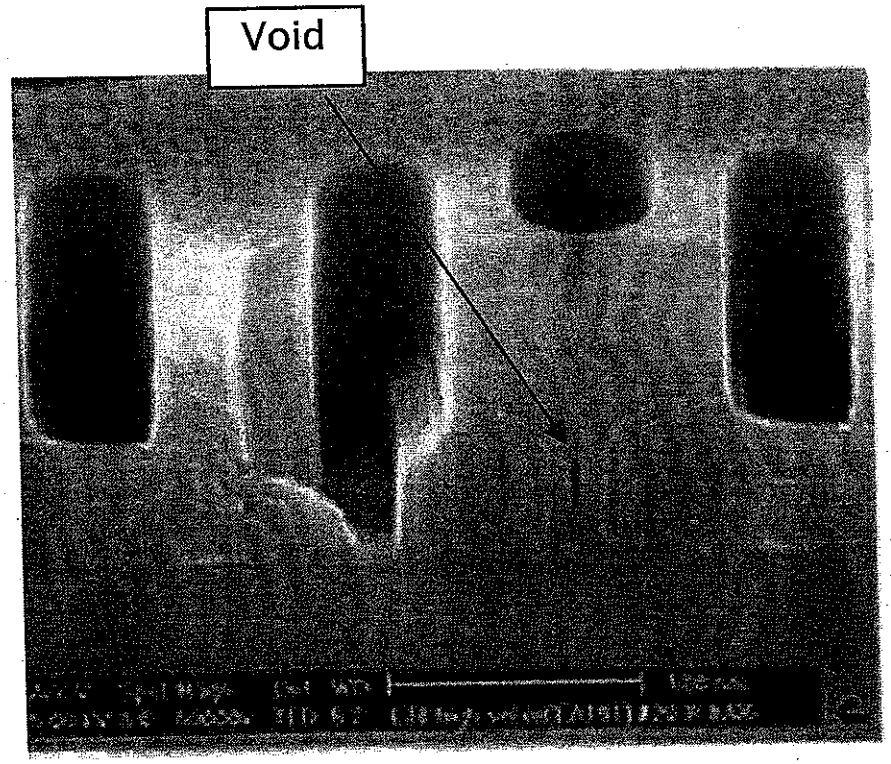
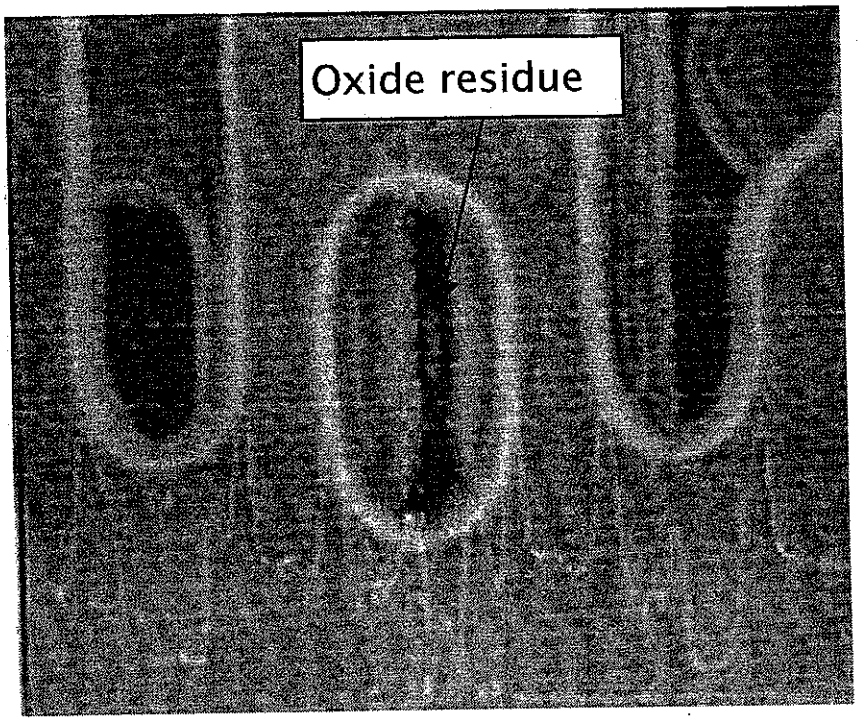


FIGURE 10.
X-SEM MICROGRAPH SHOWS VOID IN OXIDE GAP-FILLING



X-SEM MICROGRAPH AFTER HIGHLY SELECTIVE CONTACT OXIDE ETCHING SHOWS OXIDE RESIDUE WITHIN CONTACT HOLE

FIGURE 11

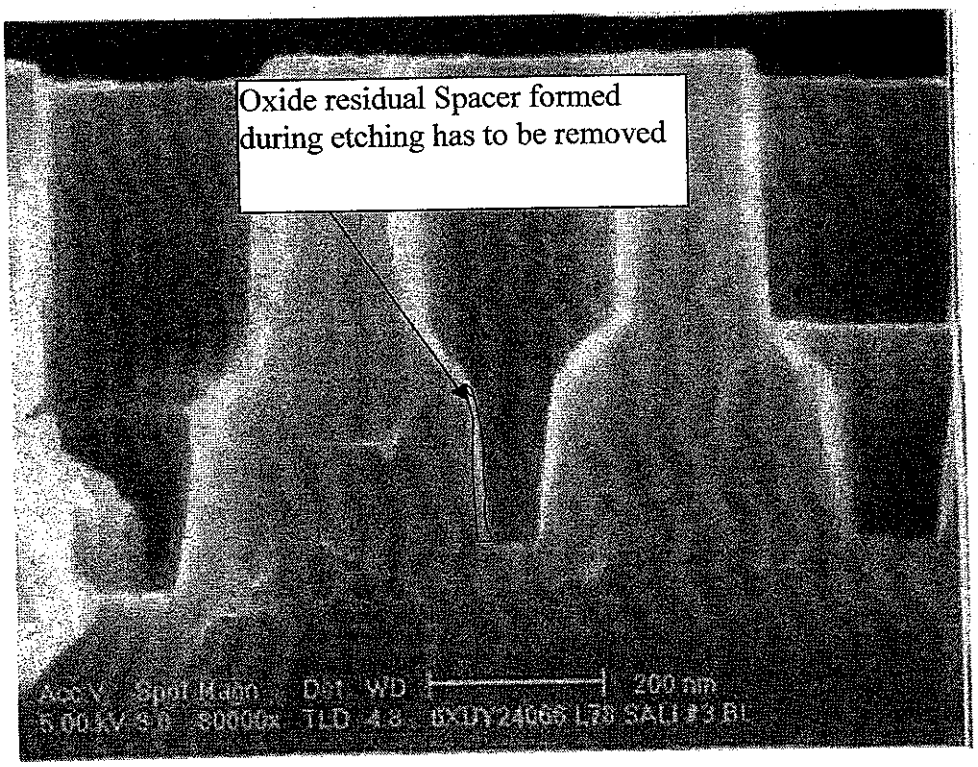


FIGURE 12